

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

## Title of Invention

METHOD FOR CONTROLLING LINEWIDTH IN ADVANCED  
LITHOGRAPHY MASKS USING ELECTROCHEMISTRY

Application Number :

Confirmation Number:

First Named Applicant: Louis Kindt

Attorney Docket Number: BUR920030115US1

Art Unit:

Examiner:

Search string: ( 5780187 or 5707765 or 5935733 or 5935737 or 6139993 or 6235434 or 6309976  
or 6368762 or 6368974 or 6627362 or 20020115000 ).pn

## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
12	1	5780187	1998-07-14	Pierrat et al.	—	—	
	2	5707765	1998-01-13	Chen	—	—	
	3	5935733	1999-08-10	Scott et al.	—	—	
	4	5935737	1999-08-10	Yan	—	—	
	5	6139993	2000-10-31	Lee et al.	—	—	
	6	6235434	2001-05-22	Sweeney et al.	—	—	
	7	6309976	2001-10-30	Lin et al.	—	—	
	8	6368762	2002-04-09	Ling	—	—	
	9	6368974	2002-04-09	Tsai et al.	—	—	
12	10	6627362	2003-09-30	Stivers et al.	—	—	

## US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
12	1	20020115000	2002-08-22	Gupta et al.			

Signature



8-11-05

Examiner Name

Date